

FORM PTO-1449 (Rev. 2-32)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 005092.00028
<div style="display: flex; align-items: center;"> <div> SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary) </div> </div>		Serial No. 10/003,837
		Applicant: Tim Peck et al
Filing Date: December 3, 2001		Group: 1632 2859

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	MM/DD/YY Date	Name	Class	Subclass	Filing Date if Appropriate
TAF	6 1 0 3 1 9 9	8/15/00	Randy McCormick et al Bjornson et al	422	100	

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Subclass	Translation	
					Yes	No
TAF 0 0 5 0 9 2 4	8/31/00	WO				
TAF 1 9 9 2 7 9 7 6	1/13/00	DE			X	

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc).

TAF	Dechow J et al: "Fabrication of NMR Microsensors for Nanoliter Sample Volumes" vol. 53, no. 1-4, June 2000 International Search Report based off of PCT/US/46733
EXAMINER 	DATE CONSIDERED March 21st 2003

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